



Inventor: Garry A. Mercaldi
Title: Low Selectivity Deposition Methods
Assignee: Micron Technology, Inc.
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INFORMATION DISCLOSURE STATEMENT
PURSUANT TO 37 C.F.R. §§1.56, 1.97 AND 1.98

In compliance with 37 C.F.R. §§1.56, 1.97 and 1.98, your attention is directed to the U.S. Patents and other documents listed on the attached Form PTO-1449, and copies of which are attached. No admission is made regarding whether the submitted references are prior art.

Citation of these references is respectfully requested.

This Supplemental Information Disclosure Statement is being filed together with the filing of the Request for Continued Examination (RCE) Application. Therefore, no fee is believed to be required. However, in the event that a fee is required for filing this Supplemental Information Disclosure Statement, please charge the fee specified under 37 C.F.R. § 1.17(p) to Deposit Account No. 23-0925. Please credit Deposit Account No. 23-0925 with any overpayment of the above fee.

Respectfully submitted,

Dated: 17 Jul 2003

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